	Notice of References Cited	Application/Control No. 10/583,420	Applicant(s)/Patent Under Reexamination GOTO, YOSHIHIRO	
		Examiner Jason Heidemann	Art Unit 2624	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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